

# MULTI-USER VACUUM SYSTEMS

INEXPENSIVE, SPACE-SAVING SOLUTIONS FOR SUPPLYING VACUUM TO DIFFERENT APPLICATIONS



SC 920 G

## QUIET

### SC 920 G Vacuum Pump System

- Flow rate up to 1,26 m<sup>3</sup>/h / Ultimate vacuum 2 mbar abs.
- Quiet operation
- Automatic, accurate recognition and monitoring of the boiling point using the integrated ramp function
- High recovery rates even with low boiling point solvents
- PPS pump head combined with PTFE-coated diaphragm are ideal for aggressive/corrosive gases and vapors
- Integrated gas ballast valve
- Speed-controlled

## LABOPORT®



SH 840 G

## CHEMICALLY RESISTANT AND CONDENSATE COMPATIBILITY

### SH 840 G Vacuum System

- Flow rate up to 2.04 m<sup>3</sup>/h / Ultimate vacuum 6 mbar abs.
- Vacuum system comprising chemically resistant diaphragm vacuum pump, base plate, condenser and separator
- Integrated gas ballast valve

## A POWERFUL PACKAGE

### N 860.3 FT.40.18 Diaphragm Vacuum Pump

- Flow rate 3.6 m<sup>3</sup>/h / Ultimate vacuum 4 mbar abs.
- Integrated KNF self-drying system ensures that condensate is quickly removed from the pump heads without the vacuum being altered. This significantly reduces process time and preserves the pump heads
- Chemically resistant and thus ideal for use with extremely aggressive/corrosive gases and vapors

## VACUUM CONTROL

### VC 900 Vacuum Control Unit

- Control of the vacuum application
- Separate control unit with pressure sensors and two-step controlled valve to be placed independently from the operating unit
- Easy to use

